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Application/Control No.	Applicant(s)/Patent under Reexamination	
10/711,916	CHEN ET AL.	
Examiner	Art Unit	
Ryan C. Jager	2816	

SEARCHED				
Class	Subclass	Date	Examiner	
397	536-7	12/20/205	RCJ	
363	60	13/21/2005	RCS	
update	above	6-19-06	RCZ	

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	

SEARCH NOT			
	DATE	EXMR	
text search	12/28/2005	pcs	
(see search notes)	C-70-6C	Kr.2	